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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Confirmation No: 6100  
Examiner: Hai Chi Pham

In Re PATENT of:

Inventor(s): Mitsuhiro OGIHARA et al.

Patent No.: 7,239,337 B2

Issued: July 3, 2007

Serial No.: 10/705,895

Filed: November 13, 2003

For: COMBINED SEMICONDUCTOR  
APPARATUS WITH THIN  
SEMICONDUCTOR FILMS

Atty. Ref.: MAE 300

**REQUEST FOR  
CERTIFICATE OF  
CORRECTION UNDER  
37 C.F.R. §1.322**

November 28, 2007

**Attention: Certificate of Correction Branch**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir or Madam:

*Certificate  
NOV 30 2007  
of Correction*

Submitted herewith is a Certificate of Correction for the above-referenced patent. This Certificate of Correction is being filed in order to correct the addresses of the first-named inventor and second-named inventor. The correct addresses should be --Tokyo (JP)--, instead of Hachioji (JP) (please see attached Declaration, which verifies the correct addresses of the Inventors). It is requested that this Certificate of Correction be entered. It is believed that no fee is due. Should any fee be required, however, the Director is hereby authorized to charge the fee to our Deposit Account No. 18-0002, and is requested to advise us accordingly.

Respectfully submitted,

November 28, 2007  
Date

Robert H. Berdo, Jr. – Reg. No. 38,075  
RABIN & BERDO, PC – Cust. No. 23995  
1101 14<sup>th</sup> Street, NW, Suite 500  
Washington, DC 20005  
(202) 371-8976 (Telephone)  
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*NOV 30 2007*

RHB/vm

## UNITED STATES PATENT AND TRADEMARK OFFICE CERTIFICATE OF CORRECTION

Page 1 of 1

PATENT NO. : 7,239,337 B2

APPLICATION NO.: 10/705,895

ISSUE DATE : July 3, 2007

INVENTOR(S) : Mitsuhiro OGIHARA, Hiroyuki FUJIWARA, Ichimatsu ABIKO, and Masaaki SAKUTA

It is certified that an error appears or errors appear in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Title page, item (75), should read:

--Inventors:

Mitsuhiro OGIHARA, Tokyo (JP);

Hiroyuki FUJIWARA, Tokyo (JP);

Ichimatsu ABIKO, Tokyo (JP);

Masaaki SAKUTA, Tokyo (JP)--.

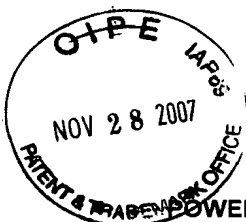
MAILING ADDRESS OF SENDER (Please do not use customer number below):

RABIN & BERDO, PC  
1101 14<sup>th</sup> Street, N.W., Suite 500  
Washington, DC 20005

This collection of information is required by 37 CFR 1.322, 1.323, and 1.324. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 1.0 hour to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Attention Certificate of Corrections Branch, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

If you need assistance in completing the form, call 1-800-PTO-9199 and select option 2.

NOV 30 2007



Attorney Reference \_\_\_\_\_

**DECLARATION FOR UNITED STATES PATENT APPLICATION,  
POWER OF ATTORNEY, DESIGNATION OF CORRESPONDENCE ADDRESS**

As a below named inventor, I hereby declare that my residence, post office address and citizenship are as stated below next to my name, and that I believe I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural names are listed below) of the subject matter which is claimed and for which a patent is sought on the invention entitled

COMBINED SEMICONDUCTOR APPARATUS WITH THIN SEMICONDUCTOR FILMS

the specification of which

☒ is attached hereto.

☐ was filed on \_\_\_\_\_, as Application Serial No. \_\_\_\_\_,  
and was amended on \_\_\_\_\_ [if applicable].

☐ was filed under the Patent Cooperation Treaty on \_\_\_\_\_,  
Serial No. \_\_\_\_\_, the United States of America being designated.

I hereby state that I have reviewed and understand the contents of the above-identified specification, including the claims. I acknowledge the duty to disclose to the Patent and Trademark Office information known to me to be material to patentability as defined in Title 37, Code of Federal Regulations, §1.56(a).

I hereby claim foreign priority benefits under Title 35, United States Code, §119 of any foreign application(s) for patent or inventor's certificate listed below and have also identified below any foreign application for patent or inventor's certificate having a filing date before that of the application on which priority is claimed:

Prior Foreign Application(s)

Date Filed	Number	Priority Claimed		Country
		Yes	No	
November 13, 2002	2002-329273	X		JAPAN

I hereby appoint the following attorneys to prosecute this application and to transact all business in the United States Patent and Trademark Office connected therewith: Steven M. Rabin (Reg. No. 29,102) and Robert H. Berdo, Jr. (Reg. No. 38,075).  
Address all correspondence to:

**\*23995\***

23995

Patent Trademark Office

The undersigned hereby authorizes the U.S. attorneys named herein to accept and follow instructions from the undersigned's assignee, if any, and/or, if the undersigned is not a resident of the United States, the undersigned's domestic attorney, patent attorney, patent agent, or patent representative as to any action to be taken in the Patent and Trademark Office regarding this application without direct communication between the U.S. attorneys and the undersigned. In the event of a change in the person(s) from whom instructions may be taken, the U.S. attorneys named herein will be so notified by the undersigned.

I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under §1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

Signature: Mitsuhiko Ogiwara Date: October 30, 2003.

First Joint Inventor: Mitsuhiko OGIHARA

Citizenship: Japan

Residence and Post Office Address: c/o Oki Digital Imaging Corporation  
550-1, Higashiasakawa-cho, Hachioji-shi, Tokyo 193-8550 Japan

Signature: Hiroyuki Fujiwara Date: October 30, 2003.

Second Joint Inventor: Hiroyuki FUJIWARA

Citizenship: Japan

Residence and Post Office Address: c/o Oki Digital Imaging Corporation  
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Signature: Ichimatsu ABIKO Date: October 30, 2003.

Third Joint Inventor: Ichimatsu ABIKO

Citizenship: Japan

Residence and Post Office Address: c/o EEG Co., LTD.  
4-11-17, Shibaura, Minato-ku, Tokyo 108-0023 Japan

NOV 30 2003

DECLARATION FOR UNITED STATES PATENT APPLICATION,  
POWER OF ATTORNEY, DESIGNATION OF CORRESPONDENCE ADDRESS

Page 2 of 2

Signature: Masaaki Sakuta Date: October 30, 2003.

Fourth Joint Inventor: Masaaki SAKUTA

Citizenship: Japan

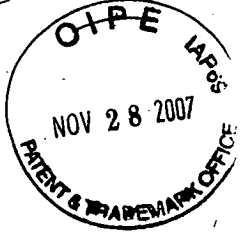
Residence and Post Office Address: c/o EEG Co., LTD.

4-11-17, Shibaura, Minato-ku, Tokyo 108-0023 Japan

NOV 30 2007



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Date Mailed

*September 26, 2007*

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OCT 10 2007

BY:.....

*MAE-300*

Patent No. : 7,239,337  
Inventor : Mitsuhiro OGIHARA et al.  
Patent Issued : July 3, 2007  
Title : COMBINED SEMICONDUCTOR APPARATUS WITH THIN SEMICONDUCTOR FILMS

Consideration has been given your request for the issuance of a certificate of correction for the above-identified patent under the provisions of Rule 1.322(a).

Accordingly, the inventors address as printed was considered in accordance with the Declaration or Oath and in accordance with the present style for printing. In assigned patents, the city and U.S. state, or city and foreign country (residence) is printed.

In view of the foregoing, applicants request in this matter is hereby denied.

Any inquiry concerning this communication should be directed to Ms. A. Green at (703) 308-9380 Ext. 123.

*Dr. Cecelia B. Newman*  
Cecelia B. Newman  
Decisions & Certificates  
of Correction Branch

(703) 308-9390 OR (703) 308-*9380 ext. 123*

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CBN/arg

*2007*